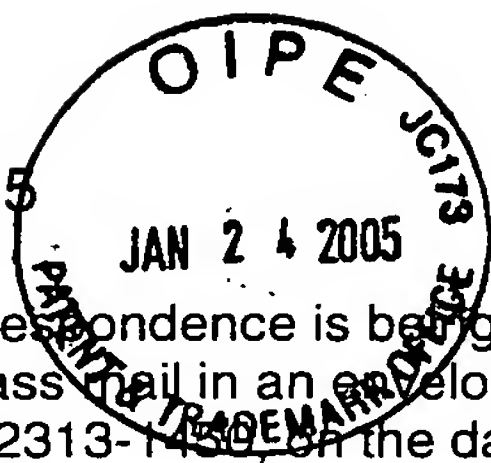


Docket No.: P2002,0645



IFW

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By: 

Date: January 18, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/632,752 Confirmation No: 4660
Applicant : Frank-Michael Kamm et al.
Filed : August 1, 2003
Title : Reflective Mirror for Lithographic Exposure and Production Method
Art Unit : 2812
Examiner : Olivia T. Luk

Docket No. : P2002,0645
Customer No. : 24131

R E S P O N S E

Hon. Commissioner for Patents

Sir:

Responsive to the Office Action dated December 21, 2004, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group II, claims 11-18, for prosecution at this time.

Applicants request a rejoinder under MPEP §821.04.

In view of the foregoing, the early issuance of an Action on the merits of claims 11-18 is solicited.

Respectfully submitted,



For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: January 18, 2005

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